

FEB 14 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/050,334
Filing Date January 15, 2002
Inventor Vishnu K. Agarwal
Assignee Micron Technology, Inc.
Group Art Unit 2813
Examiner Tuan H. Nguyen
Attorney's Docket No. MI22-1913
Title: Capacitor Fabrication Methods and Capacitor Constructions and
Enhanced Surface

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References – See Attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 14 Feb 2006

By:


James E. Lake
Reg. No. 44,854

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1913	SERIAL NO. 10/050,334				
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT: Vishnu K. Agarwal					
				FILING DATE January 15, 2002		GROUP 2813			
U.S. PATENT DOCUMENTS									
*Examiner's Initials		Document Number	Date	Name		Class	Subclass	Filing Date if Appropriate	
	AA	2005/0082593 A1	04/2005	Lee et al.					
	AB	2003/0215960	11/2003	Mitsuhashi					
	AC	6,824,816	11/2004	Aaltonen et al.					
	AD	6,307,730	10/2001	Yamanishi					
	AE	6,800,892	10/2004	Bhattacharyya					
	AF								
	AG								
	AH								
	AI								
FOREIGN PATENT DOCUMENTS									
		Document Number	Date	Country		Class	Subclass	Translation	
	AJ							Yes	No
	AK								
	AL								
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)									
	AM								
	AN								
	AO								
EXAMINER		DATE CONSIDERED							
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